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TO: COMMISSIONER FOR PATENTS & TRADEMARKS  
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FROM: Lydia McNamara  
Intellectual Property Department  
ON Semiconductor  
5005 East McDowell Road  
Phoenix, AZ 85008

Tel. (602) 244-5603  
Facsimile 602-244-3169

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ONS00535  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date: 5/23/2005  
IN RE APPLICATION OF: Peter J. Zdebel  
APPLN. NO.: 10/750267  
FILED: 1/2/2004  
FOR: HIGH ENERGY ESD STRUCTURE AND METHOD  
Group: 2822  
Examiner:

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By

Lydia McNamara  
Lydia McNamara

on:

May 23, 2005  
Date

NUMBER OF PAGES INCLUDING THIS COVER PAGE: 15

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ONS0000535

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
IN RE APPLICATION OF: Peter zdebel et al.  
FILED: 1/2/2004  
FOR: HIGH VOLTAGE ESD STRUCTURE & METHOD  
Appln. #: 10/750267  
Date: 5/23/2005

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DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.97

Honorable Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

Please consider this Information Disclosure Statement in the above application. Applicant's undersigned representative hereby certifies that each item of information contained in the attached Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. A copy of the listed prior art is enclosed herewith.

A copy of the European Search Report received in the counterpart application is also enclosed.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,  
Peter Zdebel et al.



ON Semiconductor  
Intellectual Property Dept.  
P.O. Box 62890 - A700  
Phoenix, AZ 85062-2890  
Customer #: 27255

Kevin B. Jackson  
Reg. #38,502  
Phone: 602-244-4885  
Fax: 602-244 3169

SR RPT + Written Opinion

Sheet 1 of 1

<b>FORM PTO-1449</b>  <b>U.S. DEPARTMENT OF COMMERCE</b>  <b>PATENT AND TRADEMARK OFFICE</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use several sheets if necessary)	<b>ATTY. DOCKET NO.</b> ONS00535	<b>SERIAL NO.</b> 10/750267
	<b>APPLICANT</b> Peter Zdebel et al.	
	<b>FILING DATE</b> January 2, 2004	<b>GROUP</b> 2822

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5877534	3/2/1999	Williams et al.	H01L	29/72	
	4405933	9/20/1983	Avery	H01L	29/90	
	6236087	5/22/2001	Daly et al.	H01L	23/62	

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date Pertinent Pages, Etc.)


EXAMINER	DATE CONSIDERED
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EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(Form PTO-1449)